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## TRANSMITTAL LETTER (General - Patent Pending)

Docket No. Beaumont-27

In N	Application	f: Alain Straboni				•			
Appli	cation No.	Filing Date	E	xaminer	Custom	er No.	Group Art Unit	Confirmation No.	
10/552,548 October 12, 2005 Not Ye				Yet Assigned	457	22	Not assigned	Not assigned	
Title:	SINTEREI	SEMICONDUCTO	R MATERIA	AL					
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Information Disclosure Statement (2 pgs.), Information Disclosure Citation (2 pgs.), International Search Report (4 pgs.), Cited References (10), Return Postcard									
in the	above identi	fied application.							
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

April 7, 2006

(Date)

Signature of Person Mailing Correspondence

Susan J. Quackenbos

Typed or Printed Name of Person Mailing Correspondence

Applicant: Alain Straboni : Art Unit: Not Yet Assigned

Serial No.: 10/552,548 : Docket No.: Beaumont-27

Filed: 10/12/2005 : Examiner: Not Yet Assigned

For: SINTERED SEMICONDUCTOR

**MATERIAL** 

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant submits herewith copies of references or other information of which it is aware that it believes may be material to the examination of this application, and in respect to which, there may be a duty to disclose under 37 C.F.R. § 1.56 and in accordance with 37 C.F.R. §§ 1.97-1.98.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), or an admission that the information is material to patentability (37 C.F.R. 1.97(h)), or an admission that the information constitutes prior art.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Should there be any fees due and owing with

## CERTIFICATE OF MAILING

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By: Jusan J. Quackerbos Typed or Printed Name: Susan J. Quackerbos

respect to this application, the Examiner is authorized to charge such fees to Deposit Account No. 50-3208.

The Examiner is respectfully requested to review the references identified herewith and make them of record in the instant application as required by M.P.E.P. § 609. The Examiner is also requested to initial one copy of Form PTO-1449 and return same to the undersigned.

Respectfully submitted,

Edward J. Howard

Registration No. 42,670

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Attorneys for Applicant

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INFORMATION DISCLOSURE CITATION  (Use several sheets if necessary)  APR 1 0 2006 6						Applicant(s)					
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